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Attorney's Docket No.: 12732-168001 / US6669

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	: Shunpei Yamazaki et al.	Art Unit	: 2829
Serial No.	: 10/685,398	Examiner	: Luan C. Thai
Filed	: October 16, 2003	Confirmation No.	6676
Title	: SEMICONDUCTOR APPARATUS AND FABRICATION METHOD OF THE SAME		

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR INITIALED PTO FORM 1449

Upon reviewing the file, applicants noted that they have not received an initialed copy of the enclosed PTO Form 1449 that accompanied an information disclosure statement filed September 14, 2005.

Applicants' records show that this information disclosure statement complied with 37 CFR 1.97. Thus, it is respectfully requested that the examiner initial and return this form as soon as possible. Note, applicants must pay respond to the notice of allowance by December 16, 2005, so the examiner's prompt attention to this matter would be appreciated.

Respectfully submitted,

Date: 10/4/05

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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 12732-168001	Application No. 10/685,398
Information Disclosure Statement by Applicant (Use several sheets if necessary)		Applicant Shunpei Yamazaki et al.	
(37 CFR §1.98(b))		Filing Date October 16, 2003	Group Art Unit 2829

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U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
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Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation Yes	Translation No
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature	Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.